Notice of Allowability	Application No.	Applicant(s)
	09/498,995	WATANABE, TAKAFUMI
	Examiner	Art Unit
	Jung W. Kim	2132
The MAILING DATE of this communication apperation allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	ears on the cover sheet we (OR REMAINS) CLOSED i or other appropriate comm GHTS. This application is	ith the correspondence address n this application. If not included unication will be mailed in due course. THIS
1. This communication is responsive to <u>2/13/06</u> .		
2. The allowed claim(s) is/are <u>8-17</u> .		
 Acknowledgment is made of a claim for foreign priority una a)	been received. been received in Application cuments have been receive	on No ed in this national stage application from the
4. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give	es reason(s) why the oath o	
5. CORRECTED DRAWINGS (as "replacement sheets") must be submitted.		
(a) ☐ including changes required by the Notice of Draftspers		w (P1O-948) aπached
 1) ☐ hereto or 2) ☐ to Paper No./Mail Date (b) ☐ including changes required by the attached Examiner's 		r in the Office action of
Paper No./Mail Date	S Amendment / Comment o	in the Office action of
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the		
6. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT		
Attachment(s) 1. Notice of References Cited (PTO-892) 2. Notice of Draftperson's Patent Drawing Review (PTO-948) 3. Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. Interview S Paper No. 8), 7. Examiner's	Informal Patent Application (PTO-152) Summary (PTO-413), /Mail Date S Amendment/Comment S Statement of Reasons for Allowance KAMBIZ ZAND PRIMARY EXAMINER

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DETAILED ACTION

Response to Arguments and Reasons for Allowance

1. Applicant's arguments, see Pre-appeal brief request for review, filed on February 13, 2006, with respect to the rejections have been fully considered and are persuasive. In particular, applicant's arguments (Remarks, pg. 2, last paragraph-pg. 3, first paragraph) identify portions of the disclosure that enables the features of the limitation of claim 8 under question. Hence, the 112/1st paragraph rejection of claim 8 has been withdrawn. Also, the aforementioned portions of the specification, in addition to pg. 1, lines 9-13 (Remarks, pg. 4, first paragraph), describe means that are not a structural equivalent in comparison with the invention disclosed in the lijima prior art; in particular lijima does not disclose a security flag is set while the security of an application is valid, nor does lijima disclose the command message being processed as disclosed on pg. 10, lines 10-19. These are elements corresponding to the means plus function as recited in applicant's claims. (MPEP 2181 and 2183) Hence, the prior art rejections are withdrawn and claims 8-17 are allowed.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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Communications Inquiry

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jung W. Kim whose telephone number is 571-272-3804. The examiner can normally be reached on M-F 9:00-5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gilberto Barron can be reached on 571-272-3799. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Jung W Kim Examiner Art Unit 2132

RAMBIZ ZAND PRIMARY EXAMINER

May 2, 2006